

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Fumitsugu FUKUYO et al.)	Confirmation No.: 1798
)	
Application No.: 10/507,392)	Group Art Unit: 2892
)	
Filed: April 8, 2005)	Examiner: Elias Ullah
)	
For: LASER PROCESSING METHOD)	

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop RCE
Alexandria, VA 22314

Sir:

AMENDMENT UNDER 37 C.F.R. § 1.116

In response to the final Office Action dated May 27, 2009, and pursuant to 37 C.F.R. § 1.116, the period for response to which is extended through Monday, September 28, 2009 with the concurrently filed Petition for a One-Month Extension of Time, please amend the above-identified application as follows: